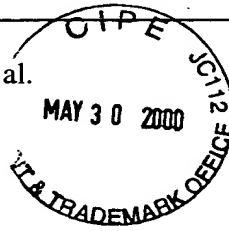


CP 1746 #4
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

8-3-00
Linda B.

In re application of: BAILEY III et al.



Attorney Docket No.: LAM1P123

Application No.: 09/470,236

Examiner: Not Yet Assigned

Filed: November 15, 1999

Group: 1746

Title: PLASMA PROCESSING SYSTEM WITH
DYNAMIC GAS DISTRIBUTION CONTROL

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, DC 20231 on May 26, 2000.

Signed: _____

Kristina Gomez
Kristina Gomez

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§1.56 AND 1.97(c)

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0388 (Order No. LAM1P123).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Ramin Mahboubian
Ramin Mahboubian
Registration No. 44,890

P.O. Box 130
Mountain View, CA 94042-0130
Telephone: (650) 961-8300

RECEIVED
JUN - 1 2000
TC 1700 MAIL ROOM